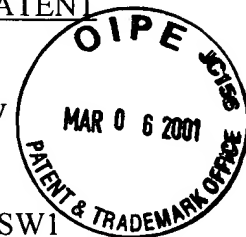


S/N 09/208,105

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	SAKAMOTO	Examiner:	O. NADAV
Serial No.:	09/208,105 ✓	Group Art Unit:	2811
Filed:	NOVEMBER 25, 1998 ✓	Docket No.:	10233.81USW1
Title:	SEMICONDUCTOR DEVICE WITH METAL WIRE LAYER MASKING (AS AMENDED HEREIN)		



CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited in the United States Postal Service, as first class mail, with sufficient postage, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on February 28, 2001.

By:

Name:

*Kristine A. Graceh*  
*Kristine A. Graceh*

AMENDMENT UNDER RULE 111

Assistant Commissioner for Patents  
Washington, D.C. 20231



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Dear Sir:

In response to the Official Action dated September 29, 2000, please amend this application as follows:

In the Specification

Please change the title from "SEMICONDUCTOR DEVICE AND A METHOD FOR MANUFACTURING THEREOF" to --SEMICONDUCTOR DEVICE WITH METAL WIRE LAYER MASKING--.

Page 1

Line 22, change "Surface" to --The surface--.

Line 24, change "17" to --22--.

Page 2

Line 8, change "irradiated" to --irradiate--.

Line 11, change "shorten" to --shortened--.

Line 15, change "90" to --80--; change "pointed out" to --possible--.